

FORM HDP-1449 (Based on Form PTO-1449)

**PATENT AND TRADEMARK OFFICE
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Sheet 1 of 1

OCT 07 2003

ATTORNEY DOCKET NO.

SERIAL NO.

45900-000611/US

09/867,606

APPLICANT

Ib JOHANNSEN et al.

FILING DATE

GROUP

May 31, 2001

2643

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date

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Technology Center 2600

FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	No

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
	BL	Ning et al., "Fabrication of a silicon micromachined capacitive microphone using a dry-etch process" Sensors and Actuators A 53 (1996) 237-242

Examiner:

B. Enay

Date Considered:

4/20/04

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.